

Application No.	Applicant(s)	
09/937,988	YAMAGISHI ET AL.	
Examiner	Art Unit	
Sheela C Chawan	2625	

SEARCHED					
Class	Subclass	Date	Examiner		
382	100, 108,	10/29/4	SLC		
	153, 199, 254, 260 274-275, 305				
V 250	274-213, 205- 203 B				
35%	223 B 223 R 246,426- 428,339.4 239.4,				
	237.1.				
215	121,12,2 365 522,523 524,52				
215 209 348	524.52				
	125		V		

INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
East, USPAF US-PER JPO, EPO, Dornel, IBM-TOB	> 10/29/CV	SCC		
IEEE, inverhance name seach	iopaloy	SCC		
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